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Form PTO 1449

(Rev. 2-32)

U.S. Department of Commerce
Patent and Trademark OfficeAtty. Docket No.
LMPY-9510Serial No.
09/975,091

Information Disclosure Statement by Applicant

Applicant:
Juergen Kleinshmidt

(Use several sheets if necessary)

Filed: October 9, 2001 Group: 2881

U.S. Patent Documents

Init.	Document No.	Date	Name	Class	Subclass	Filing Date
PJL	3,806,829	04/23/74	Duston, et al.	331	94.5	04/13/71
PJL	4,016,504	04/05/77	Klauminzer	331	94.5	04/12/76
PJL	4,309,671	01/05/82	Malyon	331	94.5S	12/18/80
PJL	4,319,843	03/16/82	Gornall	356	346	02/25/80
PJL	4,331,937	05/25/82	Brown, et al.	372	74	03/20/80
PJL	4,348,647	09/07/82	Nighan, et al.	372	74	06/05/80
PJL	4,393,505	07/12/83	Fahlen	372	57	11/03/81
PJL	4,399,540	08/16/83	Bucher	372	20	09/22/80
PJL	4,404,366	09/13/83	Boguslaski, et al.	536	18.1	07/16/81
PJL	4,435,808	03/06/84	Javan	372	11	01/22/81
PJL	4,468,773	08/28/84	Seaton	372	32	05/29/81
PJL	4,513,422	04/23/85	Buholz	372	29	06/14/83
PJL	4,558,952	12/17/85	Kulesh, et al.	356	349	02/18/83
PJL	4,592,043	05/27/86	Williams	370	3	04/24/83
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PJL	4,616,908	10/14/86	King	350	576	07/19/84
PJL	4,691,322	09/01/87	Nozue, et al.	372	82	01/22/86
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PJL	5,025,445	06/18/91	Anderson, et al.	372	20	11/22/89
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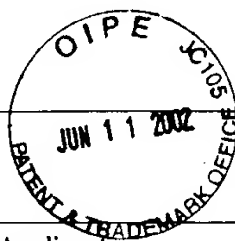
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PATRICK CONNOLLY

Date Considered

06-05-2002

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Applicant:
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Init.	Document No.	Date	Name	Class	Subclass	Filing Date
PX	5,144,632	09/01/92	Thonn	372	33	03/15/91
PX	5,150,370	09/22/92	Furuya, et al.	372	106	12/12/90
PX	5,198,872	03/30/93	Wakabayashi, et al.	356	352	05/18/90
PX	5,218,421	06/08/93	Wakabayashi, et al.	356	352	02/15/91
PX	5,221,823	06/22/93	Usui	219	121.78	01/17/92
PX	5,225,884	07/06/93	Stark, et al.	356	73	06/05/91
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PX	5,307,364	04/26/94	Turner	372	60	05/24/93
PX	5,337,330	08/09/94	Larson	372	86	10/09/92
PX	5,373,515	12/13/94	Wakabayashi, et al.	372	20	06/21/91
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PX	5,404,366	04/04/98	Wakabayashi et al.	372	29	02/14/94
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PX	5,450,207	09/12/95	Fomenkov	356	416	07/16/93
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PX	5,663,973	09/02/97	Stamm, et al.	372	20	06/10/96
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PX	5,729,562	03/17/98	Birx, et al.	372	38	10/31/96
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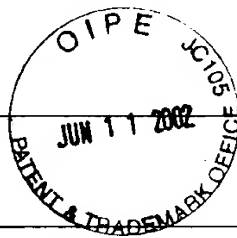
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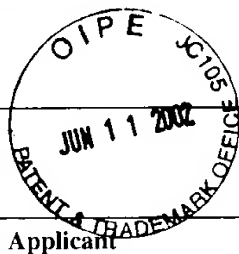
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Information Disclosure Statement by Applicant				Applicant: Juergen Kleinshmidt			
(Use several sheets if necessary)				Filed: October 9, 2001 Group: 2881			
U.S. Patent Documents							
Init.		Document No.	Date	Name	Class	Subclass	Filing Date
PJC		5,771,094	06/23/98	Carter, et al.	356	326	01/29/97
PJC		5,802,094	09/01/98	Wakabayashi, et al.	372	57	10/10/96
PJC		5,811,753	09/22/98	Weick, et al.	219	121.78	06/19/96
PJC		5,818,865	10/06/98	Watson, et al.	372	86	05/16/97
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PJC		5,852,627	12/22/98	Ershov	372	108	09/10/97
PJC		5,856,991	01/05/99	Ershov	372	57	06/04/97
PJC		5,867,514	02/02/99	Anderson	372	38	01/09/97
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PJC		5,901,163	05/04/99	Ershov	372	20	12/08/97
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PJC		5,978,391	11/02/99	Das, et al.	372	20	07/18/97
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PJC		5,978,406	11/02/99	Rokni, et al.	372	58	01/30/98
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PJC		5,999,318	12/07/99	Morton, et al.	359	572	03/09/99
PJC		6,005,880	12/21/99	Basting, et al.	372	38	03/21/97
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PJC		6,014,398	01/11/00	Hofmann, et al.	372	60	05/20/98
PJC		6,020,723	02/01/00	Desor, et al.	320	166	04/15/97
PJC		6,028,872	02/22/00	Partlo, et al.	372	38	12/15/98
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Examiner <i>PATRICIA CONNOLLY</i>					Date Considered <i>06-07-2002</i>		
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U.S. Patent Documents

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PTL	6,028,880	02/22/00	Carlesi, et al.	372	58	07/02/98
PTL	6,061,129	05/09/00	Ershov, et al.	356	328	01/22/99
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PTL	6,154,470	11/28/00	Basting, et al.	372	19	05/24/99
PTL	6,157,662	12/05/00	Scaggs, et al.	372	60	05/24/99
PTL	6,160,831	12/12/00	Kleinschmidt, et al.	372	57	03/17/99
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PTL	6,163,559	12/19/00	Watson	372	102	06/22/98
PTL	6,198,761	03/06/01	von Bergmann, et al.	372	86	09/03/99
PTL	6,212,214	04/03/01	Vogler, et al.	372	59	08/23/99
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PTL	6,243,170	06/05/01	Ershov	356	519	02/04/99
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PTL	6,243,406	06/05/01	Heist, et al.	372	59	10/14/99
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PTL	6,327,284	12/04/01	Stamm, et al.	372	32	10/14/98
PTL	6,327,290	12/04/01	Govorkov, et al.	372	61	06/14/00
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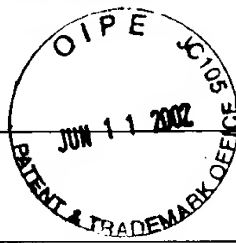
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06.07.2003

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Applicant:

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Foreign Documents

Translation

Init.	Document No.	Date	Country	Class	Subclass	Yes	No
PJL	✓ DE 40 29 687 A1	09/19/90	Germany	H01S	3/082		X
PJL	EP 0 472 727 B1	11/29/90	EPO	H01S	3/1055		
PJL	✓ DE 42 25 781 A1	08/04/92	Germany	H01S	3/08		X
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PJL	EP 0 454 399 B1	09/20/95	EPO	H01S	3/137	X	
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PJL	EP 0 875 743 A1	11/04/98	EPO	G01J	9/02	X	
PJL	DE 295 21 572 U1	12/11/97	Germany	H01S	3/028		X
PJL	DE 298 22 090 U1	02/03/99	Germany	H01S	3/08		X
PJL	DE 298 22 082 U1	02/03/99	Germany	H01S	3/08		X
PJL	EP 0 867 989 B1	09/01/99	EPO	H01S	3/1055	X	
PJL	DE 299 07 349 U1	07/06/00	Germany	H01S	3/086		X
PJL	✓ DE 199 15 741 A1	10/19/00	Germany	H01S	3/08		X
PJL	EP 1 063 503 A1	12/27/00	EPO	G01J	9/02		
PJL	WO 01/46658A1	06/01/01	PCT	G01J	3/18	(Abstract)	
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Examiner

P. H. Ruck (initials)

Date Considered

04.03.2002

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Other Documents (Including Author, Title, Date, Pertinent Pages, etc.)			
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Information Disclosure Statement by Applicant

Applicant:
Juergen Kleinshmidt

(Use several sheets if necessary)

Filed: October 9, 2001 Group: 2881

Other Documents (Including Author, Title, Date, Pertinent Pages, etc.)

Wakabayashi, et al., "Billion Level Durable ArF Excimer Laser with Highly Stable Energy," SPIE 24th Annual International Symposium on Microlithography, Santa Clara, Calif., May 14-19, 1999

A. I. Ershov, et al., "Novel Metrology for Measuring Spectral Purity of KrF Lasers for Deep UV Lithography," Proceedings of SPIE, Vol. 3677, June 1999, pp. 611-620.

Sansonetti, et al., "Precision Measurement of Wavelengths Emitted by a Molecular Fluorine Laser at 157 nm," *Applied Optics*, Vol. 40, No. 12, April 20, 2001, pp. 1974-1978.

Examiner PATRICK GANNOLLY

Date Considered 06-23-2007

Examiner: Initial if citation considered, whether or not citation is in conference with MPEP 609; Draw line through citation if not conformance and not considered. Include a copy of this form with the next communication to applicant.

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